

Notice of References Cited	Application/Control No. 10/544,210		Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner ADAM A. ARCIERO		Art Unit 1795	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-2001/0031391 A1	10-2001	Hironaka et al.	429/94
*	D	US-5,478,674	12-1995	Miyasaka, Tsutomu	429/231.3
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	M	US-			

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.